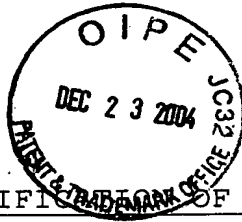


P2001,0128



CERTIFICATION OF MAILING OR TRANSMISSION

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Signature

December 20, 2004
Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/635,583 Confirmation No. 8569
Applicant : Heiko Hommen, et al.
Filed : August 6, 2003
Title : Method for Exposing at Least One or at Least
Two Semiconductors Wafers
Group Art Unit : 1756
Examiner : Christopher G. Young

Docket No. : P2001,0128
Customer No. : 24131

A M E N D M E N T

Mail Stop Amendment

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S i r :

Responsive to the Office Action dated February 9, 2004, kindly
amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.